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Honaga et al.

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(54) **JIG FOR MEASURING WITHSTAND VOLTAGE OF SEMICONDUCTOR ELEMENT**

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(**) Term: **14 Years**

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Oct. 5, 2012 (JP) 2012-024373

(51) **LOC (10) Cl.** **10-03**

(52) **U.S. Cl.**
USPC **D10/103**

(58) **Field of Classification Search**

USPC D10/78, 103; 206/710, 832; 204/228.7,
204/229.8, 230.8; 257/620, 415, E21.567,
257/228, 79, E29.151, E51.005, 330, 591,
257/E21.384, E29.198, E21.267; 438/680,
438/459, 113, 464, 462, 455, 149, 772, 762,
438/777, 786, 158, 28, 654

See application file for complete search history.

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(57) **CLAIM**

The ornamental design for a jig for measuring withstand voltage of semiconductor element, as shown and described.

DESCRIPTION

FIG. 1 is a front view of a first embodiment of the jig for measuring withstand voltage of semiconductor element, which has tapped holes used to hold a substrate provided with a semiconductor element and has a hollow to contain insulating liquid to submerge the substrate during measurement of a withstanding voltage of the element, showing our new design; FIG. 2 is a rear view thereof; FIG. 3 is a top plan view thereof; FIG. 4 is a bottom plan view thereof; FIG. 5 is a right side view thereof; FIG. 6 is a left side view thereof; FIG. 7 is a front perspective view thereof; FIG. 8 is a sectional view taken along line 8-8 of FIG. 3 thereof; FIG. 9 is a referential top plan view showing the state in use thereof; and, FIG. 10 is a referential front perspective view showing the state in use thereof. The broken line showing is for illustrative purpose only and forms no part of the claimed design.

1 Claim, 5 Drawing Sheets

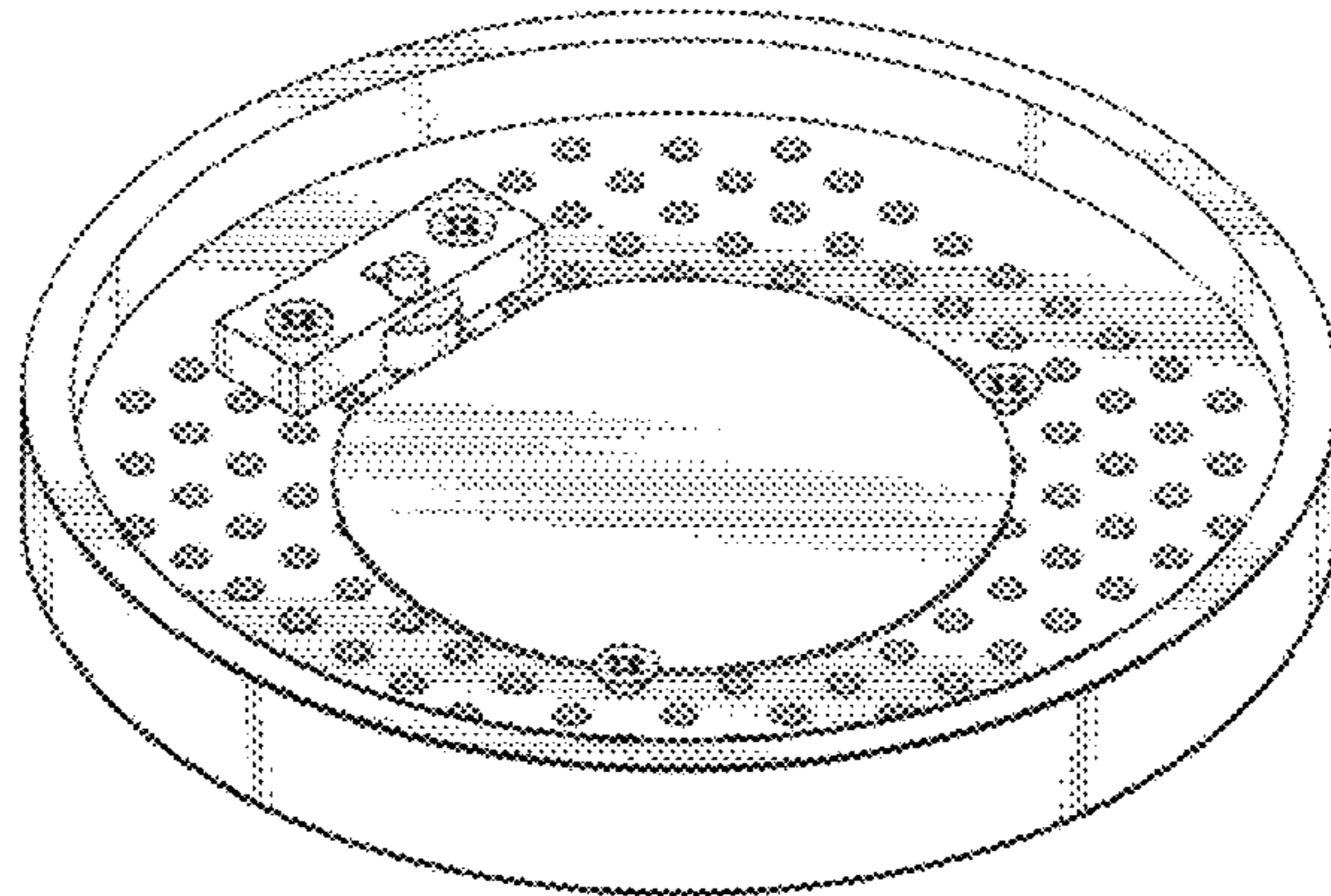


FIG. 1



FIG. 2



FIG. 3

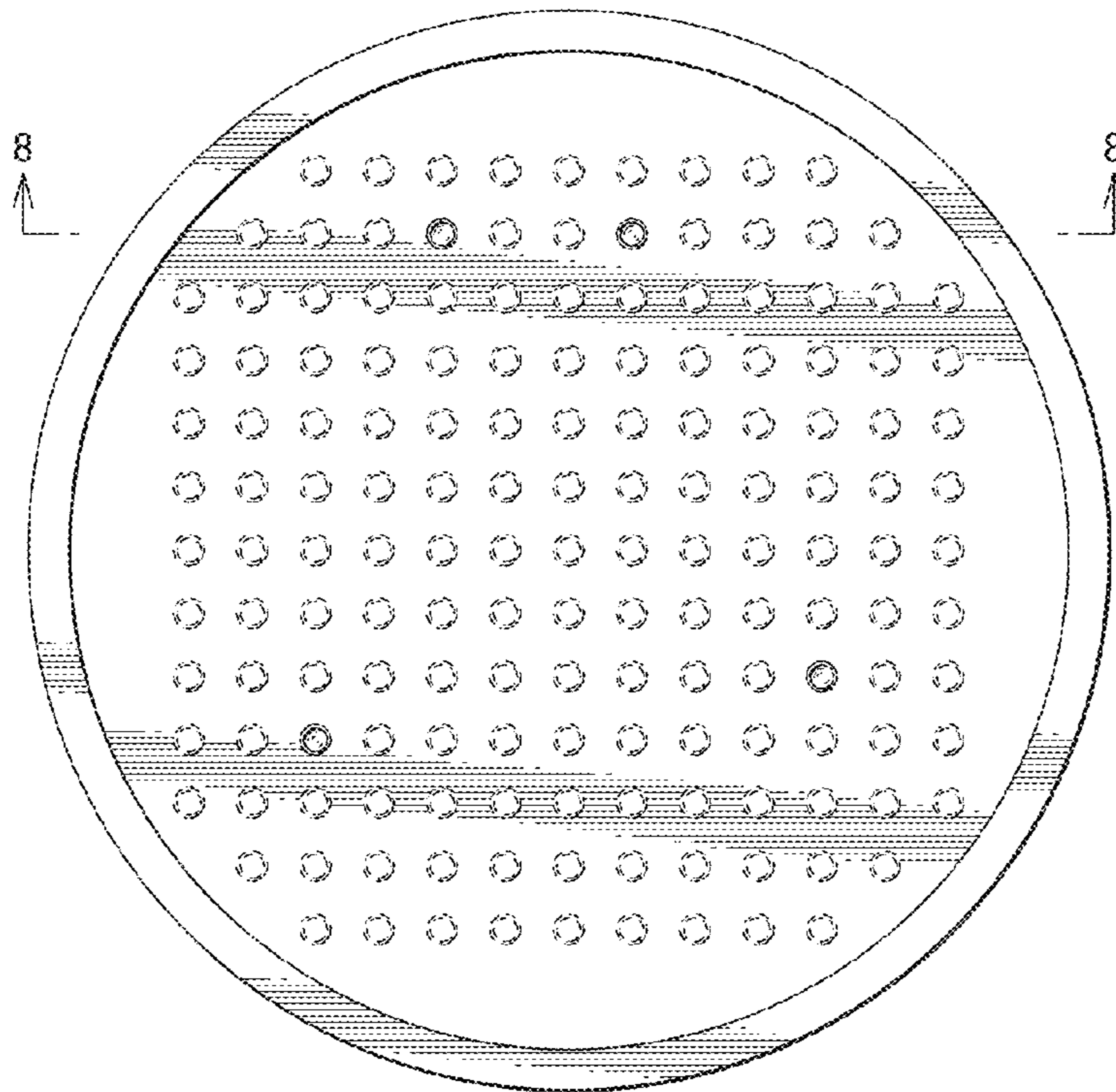


FIG.4

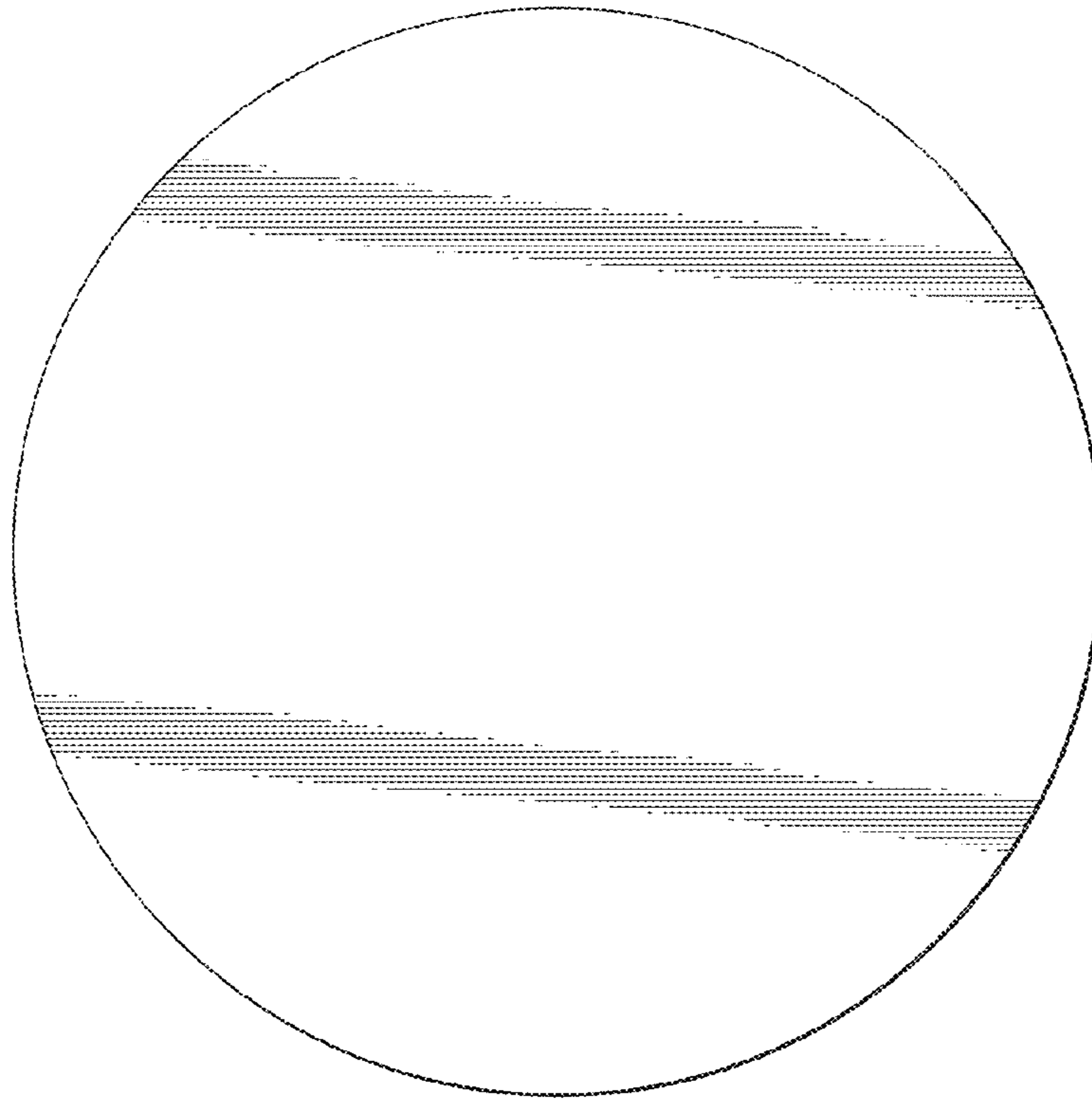


FIG.5



FIG.6

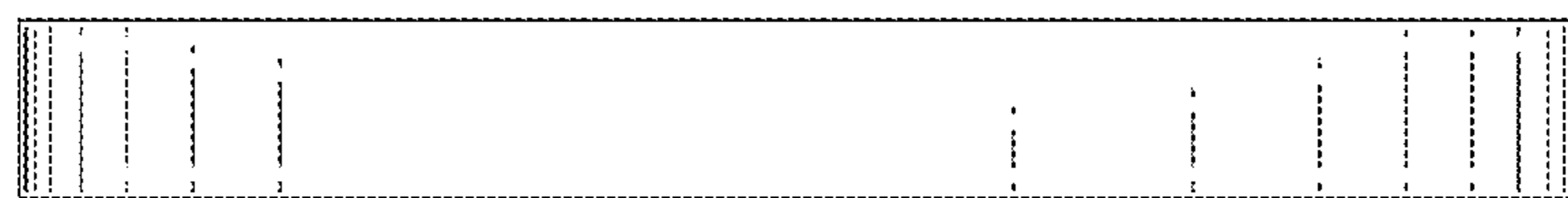


FIG.7

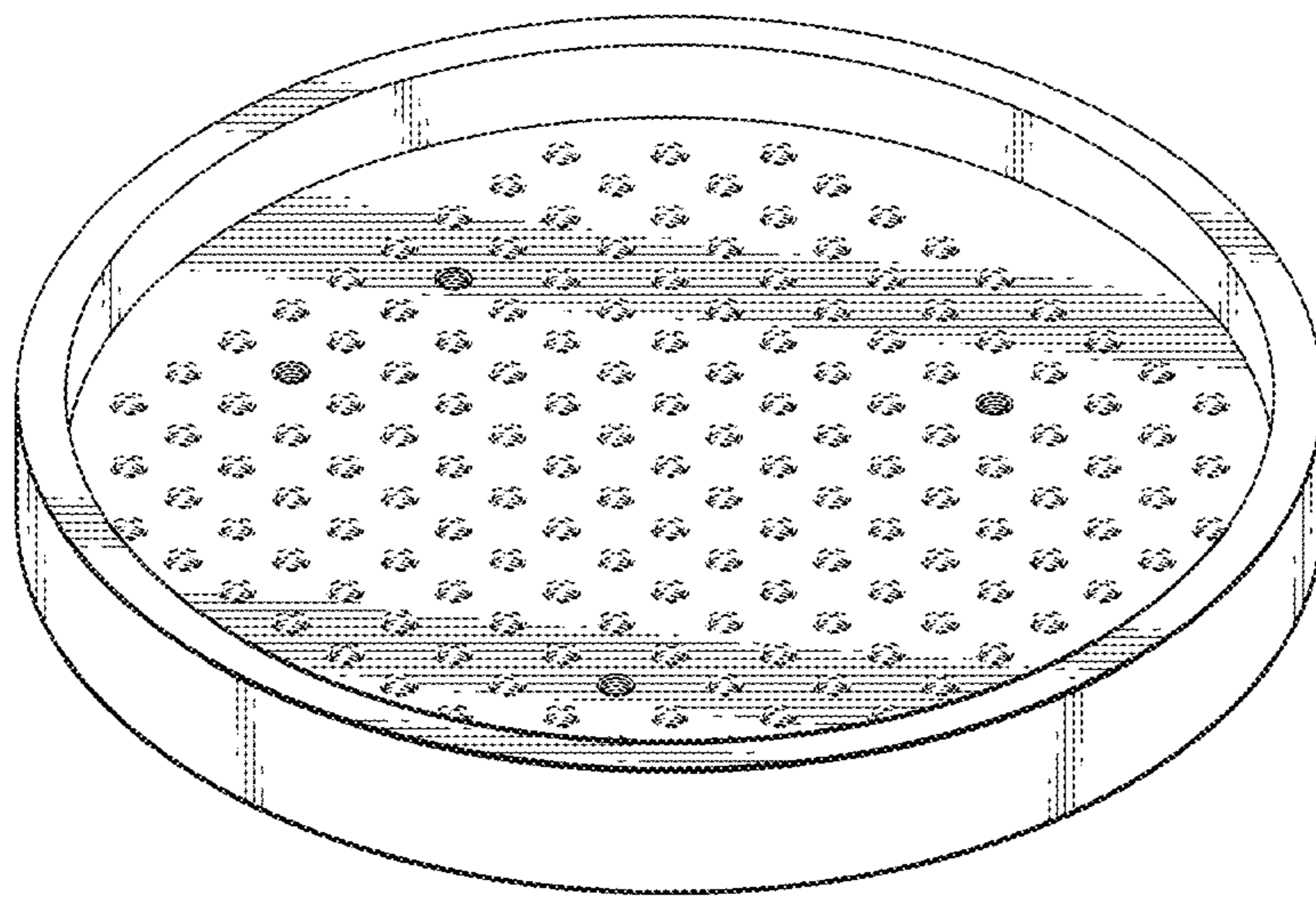


FIG.8

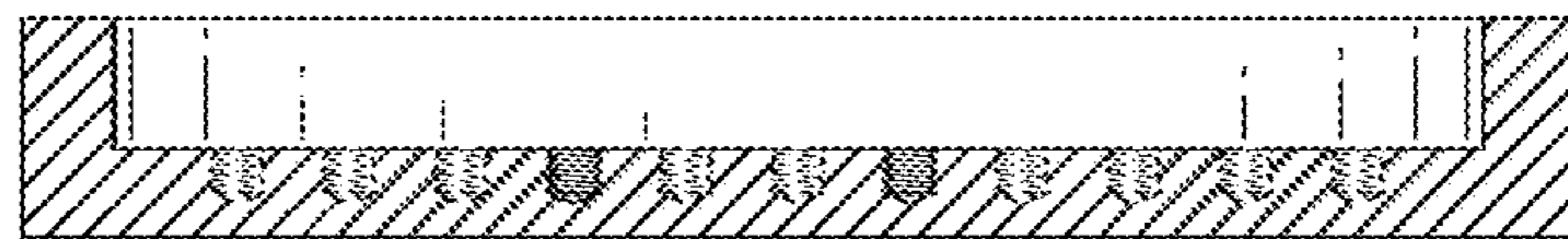


FIG.9

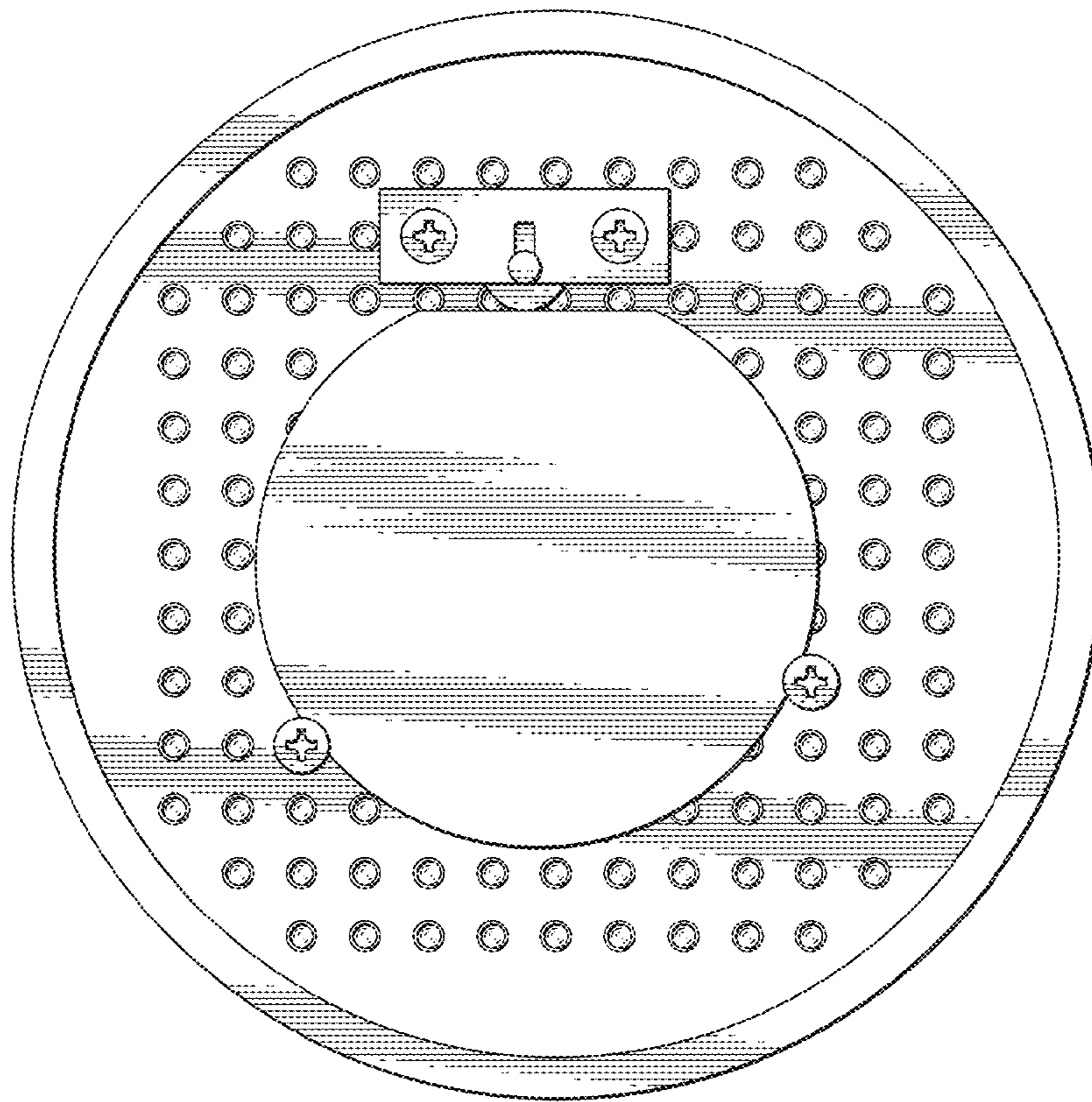


FIG. 10

